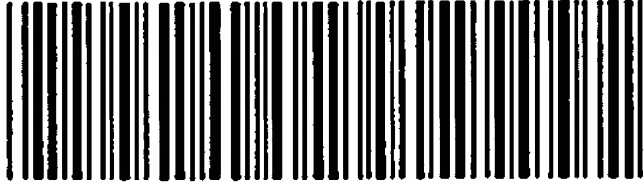


<div>Search Notes</div> <div></div>	Application No.	Applicant(s)	
	10/621,488	YAMAGUCHI, HITOSHI	
	Examiner	Art Unit	
	Anh D. Mai	2814	

SEARCHED			
Class	Subclass	Date	Examiner
257	330-331 338;341 342	4/12/2004	A.M

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	331; 338	4/14/2004	A.M
	342	4/14/2004	A.M

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST (all): * Inventors * CCLS *(power MOS) and source and drain and well and trench	4/12/2004	A.M
IEEE: * trench gate * power MOSFET	4/13/2004	A.M